

<b>Notice of References Cited</b>		Application/Control No. 09/744,793	Applicant(s)/Patent Under Reexamination MANSOUR ET AL.	
		Examiner Yelena G. Gakh, Ph.D.	Art Unit 1743	Page 1 of 1

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*	Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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B	US-			
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D	US-			
E	US-			
F	US-			
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H	US-			
I	US-			
J	US-			
K	US-			
L	US-			
M	US-			

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**NON-PATENT DOCUMENTS**

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\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
 Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.